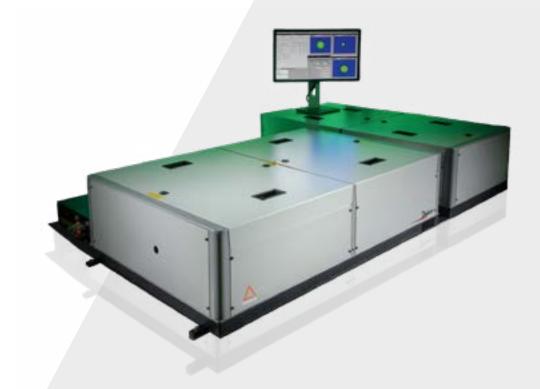
ARCO

High energy Ti:Sapphire amplifiers

The best of the Ti:Sapphire technology

Arco - the class of ultra-intense fs laser systems designed as the ideal light source for the most demanding applications. Arco amplifiers offer outstanding performance: best-in-class output parameters packaged in robust, reliable and user friendly configurations.

Arco ultrafast Ti:Sapphire lasers are built on a modular and versatile architecture and cover most exhaustive output parameter range on the ultrafast laser market.





Science:

- > High harmonic generation
- > Attophysics
- > Spectroscopy
- > Filamentation
- > Laser wakefield acceleration
- > Teraherz
- > Plasma study
- > Electron generation & acceleration



- > 10 Hz, 100 Hz, 1 kHz repetition rates
- > Pulse energy from 1 mJ to 2.7 J
- > Amplitude-made pump lasers
- > Most versatile and robust architecture
- > Peak power up to 120 TW
- > Highest performance in class
- > Pulse duration down to 20 fs
- > Hybrid systems with dual repetition rate



ARCO C (100 Hz)

Repetition Rate		100 Hz	
Energy Per Pulse (mJ) ¹	18 mJ	40 mJ	60 mJ
Pulse Width (fwhm) ¹		< 100 fs or < 35 fs or < 20 fs	
Central Wavelength (nm) ^{2,3}		800 ± 10	
Pulse To Pulse Energy Stability (RMS) ⁴		1%	
Power Stability (RMS) ⁵		1.2 %	
Nanosecond Contrast ⁶		< 5.10 ⁻⁴	
Picosecond Contrast ⁷	< 5 10 ⁻⁷ @ 300 -	· 50 ps & < 10 ⁻⁶ @ 50 - 10 ps	& < 10 ⁻⁵ @ 1 ps
Beam Quality M ²		< 1.5	
Pointing Stability		< 10 μrad RMS	
Polarization		Linear horizontal	
Warm-up Time		< 1 hour	

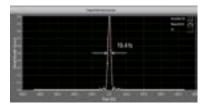
¹ Please contact factory for other energy and pulse durationlevel



User friendly laser control software



Dazzler - Acousto-Optic Programmable Dispersive



For < 20 fs duration



Options

- Down to 20 fs pulse durations
- External synchronization
- Laser 4.0 HE system control software

- Energy attenuator
- Active beam pointing control
- SHG, THG, FHG harmonic generators

² 790 nm+/- 10nm for 100fs pulse duration. Other central wavelength, please contact the factory

³ Factory set, must be specified when ordered and will be optimized prior to shipment

⁴ Over 2000 pulses

⁵ Over 8 hours under stable environmental conditions

⁶ Pre-pulse, regenerative amplifier replicas

⁷ Measured with third order cross-correlator (SEQUOIA)

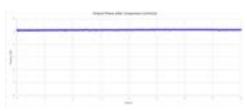
ARCO M (1 kHz)

Repetition Rate ¹		1 kHz	
Energy Per Pulse (mJ) ²	5 mJ	10 mJ	20 mJ
Pulse Width (fwhm) ³		< 100 fs or < 35 fs or < 20 fs	
Central Wavelength (nm) ⁴	800 ± 10		
Pulse To Pulse Energy Stability (RMS) ⁵	0.7 %		
Power Stability (RMS) ⁶		1%	
Nanosecond Contrast ⁷	< 5.10 ⁻⁴		
Picosecond Contrast ⁸	< 5 10 ⁻⁷ @ 300	- 50 ps & < 10 ⁻⁶ @ 50 - 10 ps &	& < 10⁻⁵ @ 1 ps
Beam Quality M ²	< 1.5		
Pointing Stability	< 10 μrad RMS		
Polarization	Linear horizontal		
Warm-up Time	< 1 hour		

¹ Please contact factory for other energy and pulse duration level



User friendly laser control software



High power stability



OPCPA Seeder



Options

- Carrier envelope phase (CEP) with OPCPA Seeder
- Down to 20fs pulse duration
- External synchronization
- User friendly laser control software

- Energy attenuator
- Active beam pointing control
- SHG, THG, FHG harmonic generators



² 790 nm +/- 10 nm for 100 fs pulse duration. Other central wavelengths, please contact factory

³ Factory-set, must be specified when ordered and will be optimized prior to shipment

⁴ Over 2000 pulses

⁵ Over 8 hours under stable environmental conditions

⁶ Pre-pulse, regenerative amplifier replicas

⁷ Measured with third order cross-correlator (SEQUOIA)

ARCO X 10 Hz high energy

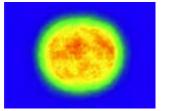
•				
Repetition Rate ¹	10 Hz 5 Hz / 10 Hz		5 Hz / 10 Hz	
Energy Per Pulse ²	25 mJ	500 mJ	1 J	> 2.7 J
Pulse Width (fwhm) ³	< 100 fs or < 35 fs or < 20 fs			
Central Wavelength (nm) ⁴	800 ± 10			
Peak Power (max)	1.25 TW	25 TW	50 TW	120 TW
Pulse To Pulse Energy Stability (RMS) ⁵	< 1,5 %			
Power Stability (RMS) ⁶	2 % over 8 hours			
Nanosecond Contrast ⁷	< 5.10 ⁻⁴			
Picosecond Contrast ⁸	< 5 10 ⁻⁷ @ 300 - 50 ps & < 10 ⁻⁶ @ 50 - 10 ps & < 10 ⁻⁵ @ 1 ps			
Beam Quality	M^2 <	1.5	Strehl rati	o > 0,85 ⁹
Pointing Stability ¹⁰	< 10 μrad RMS			
Polarization	Linear horizontal			
Warm-up Time	< 1 hour			

¹ Please contact factory for specifications at other repetition rates

Options

- Vacuum compatible compressor
- Down to 20 fs pulse durations
- External synchronization
- Laser 4.0 HE system control software
- EPICS / TANGO gateway

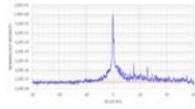
- Energy attenuator
- Active beam pointing control
- Isolation of experimental reflected beam



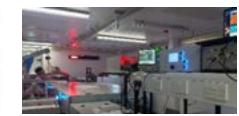
High quality beam profile (500 mJ)



Vacuum compressor for high energy



High picosecond contrast



Arco X 120 TW



² Please contact factory for specifications at other energy level

 $^{^3}$ Factory-set, must be specified when ordered and will be optimized prior to shipment. Please contact factory for specifications at other pulse duration

⁴ 790 nm +/- 10 nm for 100 fs pulse duration. Other central wavelengths, please contact factory

⁵ Over 2000 consecutive pulses

⁶ Over 8 hours under stable environmental conditions

⁷ Pre-pulse, regenerative amplifier replicas

⁸ Measured with third order cross-correlator (SEQUOIA)

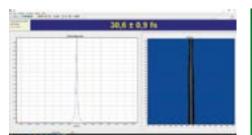
⁹ With deformable mirror option

¹⁰ Over 2000 consecutive pulses

ARCO Hybrid Dual 1 kHz and 10 Hz amplifier

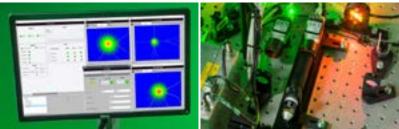
-			
Repetition Rate ¹	10 Hz & 1 kHz		
Energy Per Pulse ²	5 mJ @ 1 kHz & 25 mJ @ 10 Hz 5 mJ @ 1 kHz & 500 mJ @ 10 Hz 10 mJ @ 1 kHz & 500 mJ @ 10		
Pulse Width (fwhm) ³	< 100 fs or < 35 fs		
Central Wavelength (nm) ⁴	800 ± 10		
Energy Stability (RMS) 5	0.7% @ 1 kHz & 1.2% @ 10 Hz		
Power Stability (RMS) ⁶	2 % over 8 hours		
Nanosecond Contrast ⁷	< 5.10 ⁻⁴ @ 1 kHz & < 1.10 ⁻⁶ @ 10 Hz		
Picosecond Contrast ⁸	< 5 10 ⁻⁷ @ 300 - 50 ps & < 10 ⁻⁶ @ 50 - 10 ps		
Beam Quality M ²	< 1.5		
Pointing Stability ⁹	< 10 μrad RMS		
Polarization	Linear horizontal		
Warm-up Time	< 1 hour		

 $^{^1}$ 1 kHz - 10 Hz when 10 Hz output is activated. Please contact factory for specifications at other repetition rates



Pulse duration < 35 fs





Laser control software with beam profile monitoring for each amplifier and pump

Options

- Two independent compressed beams
- Down to 20 fs pulse durations
- Simultanous 1 kHz & 10 Hz output
- Laser 4.0 HE system control software
- Vacuum compatible compressor

- Energy attenuator
- Active beam pointing control



² Please contact factory for specifications at other energy level

 $^{^{\}rm 3}$ Factory-set, must be specified when ordered and will be optimized prior to shipment

⁴⁷⁹⁰ nm +/- 10 nm for 100 fs pulse duration. Other central wavelengths, please contact factory

⁵ Over 2000 pulses

⁶ Over 8 hours under stable environmental conditions

⁷ Pre-pulse, regenerative amplifier replicas

⁸ Measured with third order cross-correlator (SEQUOIA)

⁹ Over 2000 consecutive pulses

ARCO

Arco amplifiers offer outstanding performance: best-in-class output parameters packaged in robust, reliable and user friendly configurations.



